Attorney's Docket:

PATENT APPLICATION

TI-36749

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Christopher L. Kelley

Filing Date:

December 10, 2003

Title:

TEMPERATURE CONTROL ASSEMBLY FOR USE IN

ETCHING PROCESSES AND AN ASSOCIATED

RETROFIT METHOD

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicant respectfully requests, pursuant to 37 C.F.R. §§1.56, 1.97, and 1.98, that the document listed on the attached PTO-1449 form be considered and cited in the examination of the above-identified application. Furthermore, pursuant to 37 C.F.R. §§1.97(g) and (h), Applicant makes no representation that this document qualifies as prior art or that this document is material to patentability of the present application or that a search has been made.

Since the present Application was filed after June 30, 2003, a copy of any U.S. Patent and any U.S. Patent Application Publication cited on the attached PTO Form 1449 is not being submitted with this Information Disclosure Statement pursuant to the July 11, 2003 waiver of 37 C.F.R. S 1.98(a)(2)(i) by the U.S. Patent and Trademark Office. However, copies of articles are being furnished.

Respectfully submitted, Attorney for Applicant

Kurt M. Pankratz Reg. No. 46,977

Texas Instruments Incorporated P.O. Box 655474, MS 3999 Dallas, TX 75265 (972) 917-5557

Date: December 15, 2003

FORM PTO-1449 (REV. 7-80)

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LIST OF DOCUMENTS CITED BY APPLICANT

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APPLICANT

Christopher L. Kelley

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	СВ	"Applied Centura DPS Etch - DPS II for Metal Applications", website http://www.appliedmaterials.com/products/metal_etch_dps_ii_centura_300.html, printed on 12/4/2003, 1 page.							
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